



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Paul B. Mirkarimi et al.

Docket No. : CIL-10972

Serial No. : 10/086,614

Art Unit : 1762

Filed : March 1, 2002

Examiner : W. Markham

For : Ion-Assisted Deposition Techniques For
The Planarization Of Topological Defects

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a reply in the above identified application.

The requested extension fee for a one month extension (37 CFR 1.17(a)(1) is \$120.

The Commissioner is hereby authorized to charge this fee (\$120) to Deposit Account Number 501913.

If any impediments remain, please contact the undersigned at 808-875-0012.

Respectfully submitted,

06/28/2006 SDENB0B1 00000015 501913 10086614
01 FC:1251 120.00 DA

Dated: February 8, 2006

John P. Wooldridge
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